

<b>Notice of References Cited</b>	Application/Control No. 10/631,098	Applicant(s)/Patent Under Reexamination VOLDMAN, STEVEN H.	
	Examiner Long Nguyen	Art Unit 2816	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,242,763	06-2001	Chen et al.	257/107
*	B	US-6,015,992	01-2000	Chatterjee et al.	257/350
	C	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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